



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

# AF/2834  
# 11/B  
(NE)  
Up/row  
5/27/02

Applicant : RIBAK, E.  
Application No. : 09/613,759  
Filed : July 11, 2000  
Title : VOLTAGE AND LIGHT INDUCED STRAINS IN POROUS  
CRYSTALLINE MATERIALS AND USES THEREOF

Group/Art Unit : 2834  
Examiner : Julio C. Gonzalez

Attorney Docket No. : 00/20096

Honorable Commissioner of Patents and Trademarks  
Washington, D.C. 20231

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**RESPONSE AFTER FINAL REJECTION**

Sir:

This is in response to the United States Patent and Trademark Office Action mailed Mar. 13, 2002, which response is being made on or before June 13, 2002, and for which no extension fee is due.

This Response is based on the discussion during the telephone interview, conducted on April 25, 2002 between the Attorney for Applicant, including attendance of the inventor, Dr. Erez Ribak, and, the Examiner, Julio C. Gonzalez, including attendance of the Examiner's supervisor, Nestor Ramirez, during which the Examiner agreed to Applicant's request for filing this Response.

Please amend the above identified application as follows:

**In the Specification:**

Please replace the paragraph beginning at page 42, line 12, with the following paragraph: